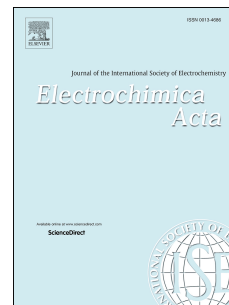


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Atomic layer deposition assisted fabrication of high-purity carbon nanocoil for electrochemical energy storage

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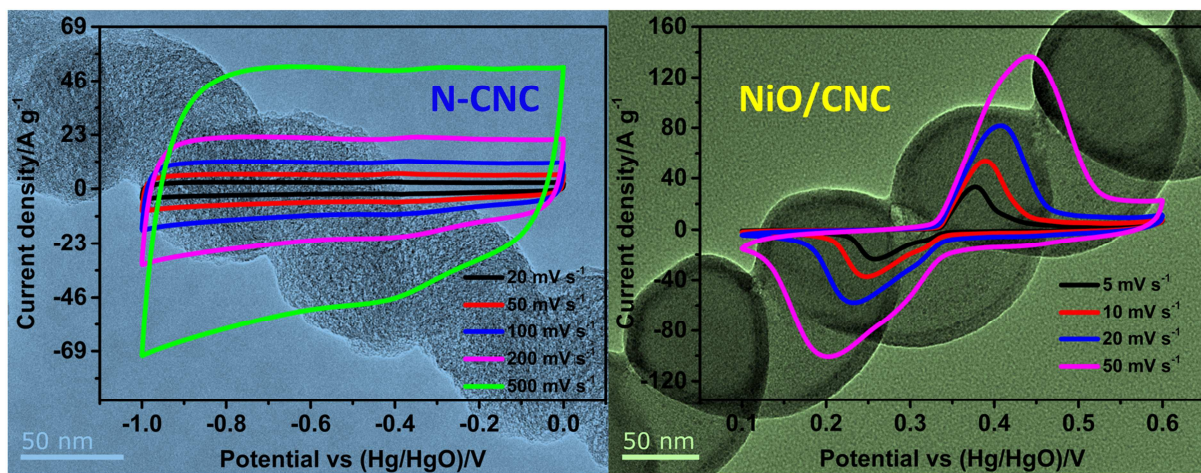
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